ME 382: Experiments in Micro and Nano Science and Engineering Department of Mechanical Engineering

Class Hours: T&Th 2:00PM - 3:20PM, Tech LG62

Laboratory Hours: WF 2:00-4:00pm and 4:00-6:00pm, Tech FG74 (choose 1 session/week) Class Instructor: Horacio Espinosa (Office: A212, Ph: 7-5989, <u>espinosa@northwestern.edu</u>) Lab Instructor: Nasir Basit (Office: FG73, Phone: 7-6201, <u>n-basit@northwestern.edu</u>)

The objectives of this course are:

- 1- To provide clean room training and basic micro/nano fabrication skills
- 2- To provide clean room operation and microfabrication equipment knowledge
- 3- To build microfluidic components, with soft lithography, and image flows using fluorescent microscopy
- 4- To provide training and experience in the utilization of scanning probe microscopy in a variety of modes
- 5- To engage students in micro/nanotechnology research.

Week #	Dates/Location	Lab Title
W1	(3/31)/Tech LG62 (3/31)/Tech LG62	Class Introduction (Espinosa) Clean Room Safety & Protocol Training (Basit)
W2	(4/6)/Tech FG74	Clean Room Tour and Safety Training (Basit)
	(4/8)/Tech FG74	(safety glasses required for all labs) Contact Aligner training & demo (Serkan)
W3	(4/13, 4/15)/Tech FG74	Contact Aligner Operation & Hands-on individual Practice (Serkan)
XX7 A	(4/19)/ Tech LG62	Design and Fabrication of Microchannels - Lithography
W4	(4/20, 2/22)/Tech FG74	with SU-8 (Serkan) Hands-on individual Practice (Serkan)
W5	(4/27, 4/29)/Tech FG74	Design and Fabrication of Microchannels- PDMS molding (Serkan) Hands-on individual Practice (Serkan)
	(5/3, 5/5)/ Tech LG62 (5/4, 5/6)/Tech FG74	Theory: microchannels and micro-PIV (Espinosa)
W6		Lab: Surface Properties and Fluid Transport in Microchannels- Contact angle measurement, flow data (Ying) Hands-on individual Practice (Ying)
	(5/10)/ Tech LG62 (5/11, 5/13)/Tech FG74	Theory: micro-PIV (Espinosa)
W7		Lab: Surface Properties and Fluid Transport in Microchannels- Additional flow data acquisition/analysis (Ying) Hands-on individual Practice (Ying)
	(5/17, 5/19)/ Tech LG62 (5/18, 5/20)/Tech FG74	Theory: AFM principles (Espinosa)
W8		Lab: AFM-1: Training & Hands-on Practice, tapping mode/fractal analysis (Shaoning) Hands-on individual Practice (Shaoning)
	(5/24)/ Tech LG62 (5/25, 5/27)/Tech FG74	Theory: AFM operation modes: Spectroscopy, Dynamic
W9		or Tapping Mode (Espinosa) Lab: AFM-2: Material Characterization (Shaoning) Hands-on individual Practice (Shaoning)
W10	(6/1, 6/3)/ Tech FG74	Lab: AFM-3: Force Spectroscopy (Shaoning) Hands-on individual Practice (Shaoning)

Course Schedule (Classes and Labs):

Grading:

HW assignments	20 %
Lab participation and individual reports	60 %
Final Project	20 %

Submissions: Reports submitted only in class or labs.

Late submission: 20%/day deduction from the full score.

Recommended references:

- Nanotribology and Nanomechanics: An Introduction 4th Edition, B.Bhushan (Editor), Springer 2017
- Fundamentals and Applications of Microfulidics, N.-T. Nguyen and S. Wereley, Artech House, 2nd Edition, 2006.
- Microsystem Design, S. D. Senturia, Kluwer Academic Publishers, 2001.
- Nanotribology and Nanomechanics I and II, Bharat Bhushan (Editor), Springer, 2011
- Scanning Probe Microscopy in Nanoscience and Nanotechnology, B. Bhushan, Springer, 2010
- Scanning Force Microscopy, D. Sarid, Oxford University Press, 1991.

Other references on microsystems:

- Fundamental of Microfabrication, Marc Madou, CRC Press, 1997.
- Introduction to Microelectronic Fabrication, Richard C. Jaeger, Addison-Wesley, 1993.
- Handbook of Nanoscience, Engineering and Nanotechnology, edited by Gooddard III, Brenner, Lyshevski and Lafrate, CRC Press, 2002.
- Mechanical Microsensors, M. Elwenspoek and R. Wiegerink, Springer Verlag, 2001.
- Silicon Micromachining, M. Elwenspoek and H. Jansen, Cambridge Press, 1999.

Access to University Facilities:

Laboratory work will take place in NUFAB clean rooms.

Lab Evaluations:

Each student must provide a lab evaluation immediately each lab. Prof. Espinosa will distribute evaluation forms in class or via e-mail.

General Guidelines:

- Each student will need to write and turn in his/her <u>individual report or homework</u>. You are encouraged to work together and discuss lab problems but make sure that the work you turn in is your own.
- Late reports will be deducted at the rate of 20% per day late. Maximum grace period is until graded report is returned.
- Instructor reserves the right to raise the final grade of any student by one letter based on participation in class and laboratory sessions.
- Attendance to class and labs is required. If you cannot come, please let the instructors know in advance. You should just send e-mail.
- Feel free to meet Professor Espinosa in his office (A212) to discuss labs or any other issues at any time. You may wish to send an e-mail to schedule an appointment.